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**\*\* CONTINUING DATA \*\*\*\*\***

NONE MM

**\*\* FOREIGN APPLICATIONS \*\*\*\*\***

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YES MM

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

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**TITLE**

Aqueous dispersion for chemical mechanical polishing, chemical mechanical polishing process, production process of semiconductor device and material for preparing an aqueous dispersion for chemical mechanical polishing